



IPW

PATENT
1215-0485P(000277-078)

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Alfred P. TURLEY Conf.: 3492
Appl. No.: 10/648,206 Group: 2811
Filed: August 27, 2003 Examiner: LOKE, S.H.Y.
For: BIPOLAR/THIN FILM SOI CMOS STRUCTURE AND
METHOD OF MAKING SAME

LARGE ENTITY TRANSMITTAL FORM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 1, 2004

Sir:

Transmitted herewith is a Reply to Restriction/Election Requirement in the above-identified application.

- ☐ The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. § 1.8.
- ☐ Petition for _____ () month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$0.00 for the extension of time.
- ☒ No fee is required.
- ☐ A check in the amount of \$0.00 is enclosed.
- ☐ Please charge Deposit Account No. 02-2448 in the amount of \$0.00. A triplicate copy of this sheet is attached.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By William L. Gates
William L. Gates, #20,848

WLG/mpe
1215-0485P(000277-078)

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Attachment(s)



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For: BIPOLAR/THIN FILM SOI CMOS STRUCTURE
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REPLY TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 1, 2004

Sir:

In reply to the Restriction Requirement dated September 3, 2004, the following remarks are respectfully submitted in connection with the above-identified application.

This reply includes: Remarks.